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**IN THE
UNITED STATES
PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Kirchner et al.

CASE: OST-041134

SER. NO.: 10/815,116

FILING DATE: March 31, 2004

FOR: METHOD FOR DISTORTION CORRECTION
IN A MICROLITHOGRAPHIC PROJECTION
EXPOSURE APPARATUS

**RESPONSE TO
OFFICE ACTION**

COMMISSIONER
FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

ATTENTION OF: Art Unit 2851

EXAMINER: Kevin C. Gutierrez

Dear Sir:

If any charges or fees must be paid in connection with the following communication, they may be paid out of our Deposit Account No. 50-0545.

This is in response to the Office Action having a mailing date of August 4, 2005.

The amendments begin on page 2 of this document.

The remarks begin on page 8 of this document.

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